

In re Application of:Docket No. 03500.014179.
YOICHI ANDO ET AL.

Application No.: 09/722,454

Filed: November 28, 2000

For: METHOD FOR MANUFACTURING ELECTRON BEAM DEVICE, METHOD FOR MANUFACTURING IMAGE FORMING APPARATUS, ELECTRON BEAM

DEVICE AND IMAGE FORMING APPARATUS MANUFACTURED THOSE MANUFACTURING METHODS, METHOD AND APPARATUS FOR MANUFACTURING ELECTRON SOURCE, AND APPARATUS FOR MANUFACTURING IMAGE

FORMING APPARATUS

Evenines M. Sentier

Examiner: M. Santiago

Group Art Unit: 2879

RECEIVED

FEB 2 6 2004

Date: February 20, 2004

THE COMMISSIONER FOR PATENTS P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED								
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL CLAIMS	40	MINUS	181	= 0	x \$9 \$18	0		
INDEP. CLAIMS	15	MINUS	17	= 0	x \$43 \$86	0		
Fee for Multiple Dependent claims \$145°/\$290								
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						0.00		

* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$\\$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicants Registration No. 4) 16
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FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)	
YOIC	CHI ANDO ET AL.	;	Examiner: M. Santiago
	ication No.: 09/722,454	;	Group Art Unit: 2879
Filed	: November 28, 2000)	
For:	METHOD FOR MANUFACTURING	:	RECEIVED
	ELECTRON BEAM DEVICE, METHOD FOR MANUFACTURING	:)	FEB 2 6 2004
	IMAGE FORMING APPARATUS, ELECTRON BEAM DEVICE AND	:)	
	IMAGE FORMING APPARATUS MANUFACTURED THOSE	:)	
	MANUFACTURING METHODS, METHOD AND APPARATUS FOR	;	
	MANUFACTURING ELECTRON SOURCE, AND APPARATUS FOR	:	
	MANUFACTURING IMAGE FORMING APPARATUS	;	February 20, 2004

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

Supplemental to the Amendment filed in the Patent and Trademark Office on February 9, 2004, please further amend the above-identified application as follows.